

IDS Form PTO/SB/08: Substitute for form 1449A/PTO			<b>Complete if Known</b>		
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)			Application Number	10/556,831	
			Filing Date	November 15, 2005	
			First Named Inventor	Claude BOURGEOIS	
			Art Unit	Unassigned	
			Examiner Name	Unassigned	
Sheet	1	of	1	Attorney Docket Number	09894.0005-00

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. <sup>1</sup>	Document Number Number-Kind Code <sup>2</sup> (if known)	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
/DR/		US-3,826,931	07-30-1974	Hammond	

**Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.**

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation <sup>6</sup>
/DR/		WO 03/017482 A1	02-27-2003	The Regents of the University of Michigan		
/DR/		JP 55-112043	08-29-1980	Seiko Instr. & Electronics Ltd.		Abstract

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation <sup>6</sup>
/DR/		Veis J., "Temperature compensation of silicon resonant pressure sensor," Sensors and Actuators A, Elsevier Sequoia S.A., Lausanne, CH, Vol. 57, No. 3, December 1, 1996, pages 179-182.	
		C. Bourgeois et al., "Design of resonators for the determination of the temperature coefficients of elastic constants of monocrystalline silicon," 1997 IEEE International Frequency Control Symposium, Orlando, FL, May 28-30, 1997, New York, New York, May 28, 1997, pages 791-799.	
		J. J. Yao, N. C. MacDonald, "A micromachined, single-crystal silicon, tunable resonator," J. Micromech. Microeng., Vol. 5, No. 3, May 28, 1997, pages 257-264.	
		Bloch, Martin et al., "Low Power Timekeeping," 43 <sup>rd</sup> Annual Symposium on Frequency Control, May 31, 1989, pages 34-36.	
		Bloch, Martin et al., "The Microcomputer Compensated Crystal Oscillator (MCXO)," 43 <sup>rd</sup> Annual Symposium on Frequency Control, May 31, 1989, pages 16-19.	
		Lanfranchi, Didier et al., "A Microprocessor-Based Analog Wristwatch Chip with 3 Seconds/Year Accuracy," IEEE International Solid State Circuits Conference, IEEE, Inc., New York, Vol. 37, February 1, 1994, pages 92-93.	
		U.S. Patent Application No. 10/556,909, filed November 15, 2005.	
		Copy of International Search Report, (PCT/CH2004/000258) mailed August 20, 2004 (3 pages).	
/DR/		Copy of International Search Report, (PCT/CH2004/000288) mailed August 20, 2004 (3 pages).	

Examiner Signature	/Derek Rosenau/	Date Considered	10/05/2007
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**EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.